Road Map of the Lecture II

CHBE320 LECTURE II MEASUREMENT, TRANSMITTERS AND FILTERING

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• Visit Sensor Block

- Kind of sensors
- Principles of the sensors
- Selection of sensors
- Noise filter

INTRODUCTION TO SENSOR

- What is Sensor?
	- Sensor converts the physical quantity to signal that can be recognized by other components such as display, transmitter and etc.

- Sensor types
	- Temperature: thermocouple, RTD, thermistor
	- Pressure: bellows, bourdon tube, diaphragm
	- Flow rate: orifice, venturi, magnetic, ultrasonic, Coliolis effect
	- Liquid level: float, differential pressure
	- pH: pH electrode
	- Viscosity: pressure drop across venturi or vane deflection
	- Composition: density, conductivity, GC, IR, NIR, UV

MEASUREMENT DEVICE

- Transducer: Sensor+Transmitter
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 CHEASUREMENT DEVICE
 CHEASE TRISE T – Transmitter generates an industrial standard signal from the sensor output.
	- Standard instrumentation signal levels
		- Voltage: 1~5VDC, 0~5VDC, -10~+10VDC, etc.
		- Current: 4~20mA (long range transmission with driver)
		- Pneumatic: 3-15psig

– Signal conversion

- I/P or P/I transducer: current-to-pressure or vice versa
- I/V (I/E) or V/I: current-to-voltage or vice versa
- P/E or E/P: pressure-to-voltage or vice versa
- Analog-to-Digital (A/D) converter
	- Continuous signal converted to digital signal after sampling
	- Specification: sample rate, resolution (8bit, 12bit, 16bit)

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TRANSMITTERS

- Transmitter Gain (K_m) : adjustable
	- Amplification ratio: (output span)/(input span)
- Span and Zero: adjustable
	- Span: magnitude of range of transmitter signal

TEMPERATURE SENSORS

(1064.43°C).

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- http://www.picotech.com/applications/thermocouple.html

RESISTANCE TEMPERATURE DETECTOR (RTD)

- Resistance changes as temperature changes.
- Platinum (Pt100Ω) is widely used. Copper (Cu) and tungsten (W) are used sometimes. (ASME 0.385Ω/ºC, JIS 0.392Ω/ºC)
- Distance between sensor and converter should be considered.
	- Connecting wire has resistance and should be compensated.

FLOW MEASUREMENT (1) FLOW MEASUREMENT (1)

Ferential Pressure Cell
 $Q = \frac{C_d A_2}{\sqrt{1 - (A_2/A_1)^2}} \sqrt{\frac{2g_c \Delta P}{p}}$
 \therefore Ap: Delta P across the orifice
 A_1 : area of forw pipe
 \therefore A₁₂: area of orifice
 $\therefore C_d$: orifice coefficient FLOW MEASUREMENT (1)

ential Pressure Cell
 $\frac{C_d A_2}{1-(A_2/A_1)^2}$ $\sqrt{\frac{2g_c\Delta P}{p}}$
 $\frac{1}{\sqrt{p}}$
 $\frac{1}{\sqrt{p$

• Differential Pressure Cell

$$
Q = \frac{C_d A_2}{\sqrt{1 - (A_2/A_1)^2}} \sqrt{\frac{2g_c \Delta P}{\rho}}
$$

- ΔP : Delta P across the orifice
- A_1 : area of flow pipe
- A_2 : area of orifice
- C_d : orifice coefficient
- FLOW MEASUREMENT (1)

Differential Pressure Cell
 $Q = \frac{C_d A_x}{\sqrt{1 (A_2/A_1)^3}} \sqrt{\frac{B_d A^2}{\rho}}$
 \therefore Ap: Delta P across the orifice
 A_x ; area of flow pipe
 \therefore A_j: area of flow pipe
 \therefore A_j: area of flow pipe
 \there total line pressure FLOW MEASUREMENT (1)

Differential Pressure Cell
 $Q = \frac{C_0 A_2}{\sqrt{1 - (A_1/A_1)^2}} \sqrt{\frac{2a_1 A P}{p}}$
 \therefore Ap: Delta P across the orifice
 A_1 : area of orifice
 \therefore C₂: area of orifice
 \therefore C₂: area of orifice
 \therefore
- important for the reading precision

FLOW MEASUREMENT(2)

• Vortex Flow Meter

- The vortices create low and high $\frac{500}{90}$ pressure zones behind the bluff body.
- FLOW MEASUREMENT (1)

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C **FLOW MEASUREMENT(2)**

Control Pressure Cell
 $\frac{1}{\sqrt{1-\frac{1}{2}t^2}}$
 $\frac{1}{\$ – The vortex meter uses a piezoelectric crystal sensor to detect the pressure exerted by the vortices on the sensing wing.
	- The piezoelectric crystal converts this vortex shedding frequency into electrical signals.
	- Electromagnetic Flow Meter
		- Electrically conducting fluid passing through a magnetic field created by the device.

CORIOLIS FLOWMETER (3)

- Flow rate is measured by Coriolis effect (1835)
- Mass flowrate, vol. flowrate, temp. and density are simultaneously measured.

FLOW MEASUREMENT (4)

- Ultrasonic Flow Meter
	- High accuracy

- Positive Displacement Flow Meter
	- Turbine, gear, wheels
- Thermal Dispersion Flow Meter
	- Flow over heating coil will change temperature

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SELECTION OF FLOWMETERS

LEVEL MEASUREMENT

WEIGHT MEASUREMENT

- Strain Gauge Load Cell
	- Replacement of mechanical balance when electrical signals is required (force is converted to electrical signal)
	- Usually 4 strain gauges are mounted on a structure such as beam
	- Two for measuring tension and two for compression (change in
	- resistance) • Wheatstone bridge
	- Types
		- Bending beam
		- Ring (Pancake)
		- Shear beam, etc.
	- Advantages/Disadvantages
		- High accuracy $(0.03\% 0.1\%)$
		- Produced in various forms and shapes
		- Accuracy degradation when the load is moving

OTHER MEASUREMENTS

- Composition measurements
	- Expensive
	- Long time delay
	- High maintenance cost
	- Gas Chromatography
	- IR, NIR, Raman, UV spectrophotometer
	- pH sensor electrode: concentration of [H+]
	- Dissolved oxygen, conductivity, etc.
- Secondary Measurements
	- Density or temp. for binary composition
- Soft Sensors
	- Estimated by a model based on other measurements

MEASUREMENT USING NIR

- Near InfraRed (NIR) Light
	- Depending on the wave length of light
		- Near IR: 0.7-2.5um
		- Mid IR: $2.5-10 \mu m$
		- Far IR: 10-1000um

- Different molecular bonds absorb different wave length of light and it is converted to the vibration of the molecules.
	- O-H bond in water
	- C-H bond in organic substance or fat
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• NIR Sensor

- Using filter wheel in front of light source, different wave length of the light is emitted as pulse.
- The concentration is obtained by analyzing the spectrum of reflected light.

FILTERING

- Noise Source
	- Process nature (turbulence, vibration, oscillation…)
	- Various noise source from environment
	- Power line, electromagnetic force, etc.
- Removing noise $d\nu_r$

- Analog filter
$$
\tau_F \frac{dy_F}{dt} + y_F = y
$$
 \longleftarrow Measured output

Filter time constant Filtered output

– First-order filter analogy

$$
\frac{y_F - y_F^0}{\Delta t} + y_F = y
$$
 Previous filtered output

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\n• Noise Source
\n- Process nature (trubulence, vibration, oscillation...)
\n- Various noise source from environment
\n- Parious noise source from environment
\n- Paroving noise
\n- Analyf filter
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$$
\tau_F \frac{dy_F}{dt} + y_F = y
$$
\n- **Message output**
\n- First-order filter analogy
\n
$$
\tau_F \frac{y_F - y_F^0}{\Delta t} + y_F = y
$$
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$$
y_F = \alpha y_F^0 + (1 - \alpha)y
$$
 where $\alpha = \frac{\tau_F/\Delta t}{1 + \tau_F/\Delta t}$ ($0 < \alpha < 1$)
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• Measurement of properties using NIR

- Composition or contents
	- Moisture
	- Fat
	- Protein
	- Sugar
	- Nicotine
	- Caffeine
	- Etc.
- Physical dimensions
	- Coating weight)
	- Film thickness
	- Etc.

- The filter behaves as an interpolation between the measured output and previous filtered output.
- If α =1, the measured output is ignored. (constant)
- If α =0, the filtered output is same as the measured output (no filtering)
- If τ_F =0, α =0 and no filtering is achieved.
- If $\tau_F = \infty$, $\alpha = 1$ and the measured output is ignored.
	- \Rightarrow As τ_F increases, heavier filter is applied.

